

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )  
)  
Nozawa et al. )  
)  
Serial No.: 10/771,997 )  
)  
Filed: February 4, 2004 )  
)  
For: Manufacturing Method And Apparatus of )  
Phase Mask Shift Blank )  
)  
Examiner: Rodney Glenn McDonald )  
)  
Confirmation No.: 4072 )  
)  
Art Unit: 1753 )

### AMENDMENT F

Commissioner of Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants have the following response to the Office Action of October 17, 2006, a one month extension of time being submitted herewith.

Please amend the above-identified application as follows: